



**RESPONSE UNDER 37 C.F.R.
§1.116 EXPEDITED PROCEDURE
EXAMINING GROUP 2891**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Shinya Ito	Examiner:	Asok K. Sarkar
Serial No:	10/763,315	Art Unit:	2891
Filed:	January 23, 2004	Docket:	17381
For:	SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME	Dated:	April 13, 2006

Confirmation No. 7794

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

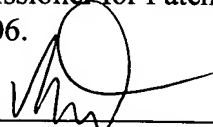
Sir:

In response to the final office action of December 28, 2005, the Applicants submit the following response.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Mail Stop AF, P.O. Box 1450, Alexandria, VA 22313-1450, on April 13, 2006.

Dated: April 13, 2006



Richard J. Danyko